

DOCKET NO: VSEA 05-99

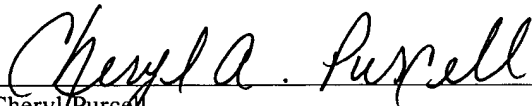
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Charles M. McKenna et al.
Serial No: 09/602,059
Confirmation No: 9493
Filed: June 23, 2000
For: ION IMPLANTER HAVING TWO-STAGE DECLARATION
BEAMLINE
Examiner: Mary A. El-Shammaa
Art Unit: 2881

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The undersigned hereby certifies that this document is being placed in the United States mail with first-class postage attached, addressed to Commissioner for Patents, Washington, D.C. 20231, on the 6th day of May, 2003.


Cheryl Purcell

Commissioner for Patents
Washington, D.C. 20231


Sir:

Transmitted herewith are the following documents:

- ☒ Amendment
- ☒ Petition for Extension of Time
- ☒ Return Receipt Postcard

If any additional fees are determined to be required or if there are any overpayments, Deposit Account 50-0896 may be charged or credited. A duplicate of this sheet is enclosed.

Respectfully submitted,
Charles M. McKenna et al., Applicants

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